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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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RADEMAR							
	re application of: Rosengaus et al.				Attorney Docket No.: KLA1P001C1		
Appli	Application No.: 09/474,941				Examiner: Rosenberger, R.		
Filed	December 30,	1999		Group: 2877			
Title:	SYSTEM AN INSPECTING WAFERS						
				hereby certify that this	correspondervice as First	F MAILING cnce is being deposited with the Class Mail to: Box Non-Fee ents, Washington, DC 20231 on I. Dean	
Box Non-Fee Amendment Commissioner for Patents Washington, DC 20231						JAN 19 2001 TECHNOLOGY CENTER 2800 clication.	1101
Sir:						E .	
	Transmitted he	rewith is an A	mendment in	the above-ident	ified app	olication.	
	The fee has been calculated as shown below.						
TOTAL Y	Claims Remaining After <u>Amendment</u>	Highest Previously <u>Paid For</u>	Present <u>Extra</u>	SMALL EN RATE FEE	NTITY	LARGE ENTITY RATE FEE	
TOTAL CLAIMS	18	_22	0	X 9 = \$	OR	X18 = \$0	
INDEP CLAIMS	4	_4	_0	X40 = \$	OR	X80 = \$0	
	ole Dependent C Not Previously		\$135=\$0		\$270= \$0		
una 1 00	1,00110,10001		TOTAL	\$		\$0	
	Applicant(s) hereby petition for a(s) extension of time to respond to aforementioned Office Action .						
	Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0388.						
	Enclosed is our	Check No.	in the a	mount of \$	to	cover the additional	

claim fee and/or extension of time fees.

Enclosed is an Associate Power of Attorney for this application.

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Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 50-0388 (Order No.KLA1P001C1). A copy of this sheet is enclosed.

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP

Phillip P. Lee Reg. No. 46,866

P.O. Box 778 Berkeley, CA 94704-0778 (650) 961-8300

PATENT

IN THE UNITED STATES PATENT AND TRAD

In re application of: Rosengaus et al.

Attorney Docket No.: KLA1P001C1 //24/0/
Examiner: Rosert

Application No.: 09/474,941

Examiner: Rosenberger, R.

Filed: December 30, 1999

Group: 2877

Title: SYSTEM AND METHOD FOR

INSPECTING SEMICONDUCTOR

WAFERS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Box Non-Fee Amendment Commissioner for Patents, Washington, DC 20231 on January 9, 2001.

Printed Name: Laura M. Dean

<u>AMENDMENT B</u>

Box Non-Fee Amendment Commissioner for Patents Washington, D.C. 20231

Dear Sir:

TECHNOLOGY CENTER 28

In response to the Office Action dated October 12, 2000, a response to which is due January 12, 2000, please enter the following amendments and consider the following remarks.

IN THE CLAIMS:

Please **CANCEL** claims 3 and 8 without prejudice or disclaimer.

Please **AMEND** claims 1, 4, 6, and 17 as follows:

- 1. (Three Times Amended) An integrated circuit manufacturing system comprising:
- (a) a plurality of interrelated integrated circuit manufacturing tools capable of operating in parallel on a plurality of semiconductor wafers, wherein the plurality of interrelated integrated circuit manufacturing tools comprise a cluster tool;

KLA1P001C1/MRO/PPL

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